

Message Text

CONFIDENTIAL

PAGE 01 OECD P 17249 031015Z

14

ACTION COME-00

INFO OCT-01 CIAE-00 DODE-00 EB-07 NSAE-00 TRSE-00 EUR-12

ERDA-05 ISO-00 EA-06 ACDA-05 /036 W

----- 040615

R 031008Z JUL 75

FM USMISSION OECD PARIS

TO SECSTATE WASH DC 7818

C O N F I D E N T I A L OECD PARIS 17249

EXCON

E.O. 11652 XGDS1

TAGS: ESTC, COCOM, PL, US

SUBJECT: US VACUUM DEPOSITION SYSTEM TO POLAND - IL 1204

REFS: A. COCOM DOC. (75) 1186 (A-2131)

B. USOECD PARIS 9016

C. STATE 135212

1. AS ANTICIPATED, REF A WAS CHALLENGED WHEN IT CAME BEFORE COMMITTEE JULY 1. FRENCH AND UK DELS BOTH RESERVED PENDING ANSWER TO QUESTIONS. FRENCH ARGUED THIS SYSTEM WAS USED MOSTLY FOR COATING CERAMIC WAFERS, AND ASKED WHETHER IT COULD NOT ALSO BE USED FOR MONOLITHIC CAPACITORS. IN VIEW OF ITS ADVANCED NATURE THEY WERE CONCERNED ABOUT THE RISK OF DIVERSION. PENDING RECEIPT OF US COMMENTS ON THESE POINTS THEY RESERVED THEIR POSITION.
2. UK SHARED FRENCH CONCERNS. THEY ASKED WHY A FULLY AUTOMATED SYSTEM DESIGNED FOR LARGE-VOLUME PRODUCTION WAS CONSIDERED NECESSARY FOR RESEARCH AND DEVELOPMENT.
3. USDEL DREW ON REF C IN REPLY BUT IT DID NOT SATISFY FRENCH AND BRITISH. FRENCH SAID IT WAS PRECISELY THE MULTIFUNCTIONAL CHARACTER OF THE SYSTEM THAT WORRIED THEM. SINCE IT HAD NO COOLING SYSTEM, IT WAS NOT SUIT-

CONFIDENTIAL

PAGE 02 OECD P 17249 031015Z

ABLE FOR PRODUCTION OF OPTICAL DEVICES, AND IT WAS CA-

PABLE OF MASS PRODUCTION OF ELEMENTS OTHER THAN MIRRORS
AND LENSES.

4. JAPANESE DEL APPROVED CASE BUT REITERATED VIEWS EX-
PRESSED IN LIST REVIEW ON TRANSFER OF 1204 COVERAGE TO
1355.

5. FOREGOING IS FROM USDEL'S NOTES. DRAFT RECORD WILL
BE POUCHED.

6. ACTION REQUESTED: INSTRUCTIONS FOR REPLY TO FRENCH
AND UK DELS.
TURNER

CONFIDENTIAL

NNN

Message Attributes

Automatic Decaptioning: X
Capture Date: 01 JAN 1994
Channel Indicators: n/a
Current Classification: UNCLASSIFIED
Concepts: ELECTRONIC EQUIPMENT, STRATEGIC TRADE CONTROLS, EXCEPTIONS LIST, IL 1204
Control Number: n/a
Copy: SINGLE
Draft Date: 03 JUL 1975
Decaption Date: 01 JAN 1960
Decaption Note:
Disposition Action: RELEASED
Disposition Approved on Date:
Disposition Authority: GarlanWA
Disposition Case Number: n/a
Disposition Comment: 25 YEAR REVIEW
Disposition Date: 28 MAY 2004
Disposition Event:
Disposition History: n/a
Disposition Reason:
Disposition Remarks:
Document Number: 1975OECDP17249
Document Source: CORE
Document Unique ID: 00
Drafter: n/a
Enclosure: n/a
Executive Order: X1
Errors: N/A
Film Number: D750230-0998
From: OECD PARIS
Handling Restrictions: n/a
Image Path:
ISecure: 1
Legacy Key: link1975/newtext/t19750787/aaaadahy.tel
Line Count: 73
Locator: TEXT ON-LINE, ON MICROFILM
Office: ACTION COME
Original Classification: CONFIDENTIAL
Original Handling Restrictions: n/a
Original Previous Classification: n/a
Original Previous Handling Restrictions: n/a
Page Count: 2
Previous Channel Indicators: n/a
Previous Classification: CONFIDENTIAL
Previous Handling Restrictions: n/a
Reference: 75 COCOM DO(71186, 75 (A-213
Review Action: RELEASED, APPROVED
Review Authority: GarlanWA
Review Comment: n/a
Review Content Flags:
Review Date: 14 MAY 2003
Review Event:
Review Exemptions: n/a
Review History: RELEASED <14 MAY 2003 by ShawDG>; APPROVED <09 JUN 2003 by GarlanWA>
Review Markings:

Margaret P. Grafeld
Declassified/Released
US Department of State
EO Systematic Review
06 JUL 2006

Review Media Identifier:
Review Referrals: n/a
Review Release Date: n/a
Review Release Event: n/a
Review Transfer Date:
Review Withdrawn Fields: n/a
Secure: OPEN
Status: NATIVE
Subject: US VACUUM DEPOSITION SYSTEM TO POLAND - IL 1204
TAGS: ESTC, PL, US, COCOM
To: STATE
Type: TE
Markings: Margaret P. Grafeld Declassified/Released US Department of State EO Systematic Review 06 JUL 2006